



PATENT  
Attorney Docket No. 29925/39028

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

Jae-Chang Jung et al.

Serial No. 10/619,254

Filed: July 14, 2003

For: Organic Anti-Reflective Coating  
Composition And Method For  
Forming Photoresist Patterns Using  
The Same

Group Art Unit: 1752

Examiner: Richard L. Schilling

I hereby certify that this paper is being  
deposited with the United States Postal  
Service as first class mail, postage  
prepaid, in an envelope addressed to:  
Mail Stop Amendment, Commissioner  
for Patents, P.O. Box 1450, Alexandria,  
VA 22313-1450 on this date:

December 12, 2005

*Andrew M. Lawrence*  
Andrew M. Lawrence, Reg. No. 46,130  
Attorney for Applicants

PETITION UNDER 37 C.F.R. § 1.136(a)

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicants, by their attorney, petition for a one-month extension of time to  
respond to a final official action dated August 12, 2005.

The Commissioner is authorize to charge our deposit account no. 13-2855 the  
large entity patent application processing fee of \$120.00.

Any additional required fee may be charged, or any overpayment credited, to  
our Deposit Account No. 13-2855.

Respectfully submitted,

MARSHALL, GERSTEIN & BORUN LLP

December 12, 2005

12/15/2005 FMETEK11.00000101 10619254

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*Andrew M. Lawrence*  
Andrew M. Lawrence, Reg. No. 46,130  
Attorney for Applicants  
6300 Sears Tower  
233 S. Wacker Drive  
Chicago, Illinois 60606-6357  
(312) 474-6300